



DO NOT ENTER: /J.L./

11/06/2008

1/K AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

ITOH ET AL.

Atty. Ref.: 1035-646; Confirmation No. 4549

Appl. No. 10/589,003

TC/A.U. 2812

Filed: August 10, 2006

Examiner: Jae LEE

For: GROUP I-VII SEMICONDUCTOR SINGLE CRYSTAL THIN FILM AND PROCESS
FOR PRODUCING SAME

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October 30, 2008

Mailbox AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL REJECTION
AND REQUEST FOR RECONSIDERATION**

In response to the Final Office Action, dated August 20, 2008, Applicants amend the
above-identified application in the following manner: